

INFORMATION DISCLOSURE STATEMENT

Case Name. D.W. Carr 3-10-3
 Applicant: D.W. Carr, et al.

JP929 U.S. PRO
 09/872306



U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
PP	AA	5,995,688	11/30/99	Aksyuk et al.	385	14	6/1/98
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation
	AG						
	AH						

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

PP	AI	Yoshihiko Imanaka et al, "Thin Film Metallization for Aluminum Nitride", <u>Electroceramics in Japan III, 2000, pp.129-134</u>
PP	AJ	Lin et al, "On the Expandability of Free-Space Micromachined Optical Cross Connects," <u>Journal of Lightwave Technology, vol. 18, pp 482-489 (April 2000)</u>



EXAMINER

John Z. Pritchett

DATE CONSIDERED

10/16/02

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

	AK	Lin et al, "Free-Space Micromachined Optical Switches for Optical Networking," IEEE Journal of Selected Topics in Quantum Electronics, vol 5, pp 4-9 (January/February 1999).)
	AL	Hecht, J., "All Optical Networks Need All Optical Switches, <u>Laser Focus World</u> , pp189-196 (May 2000).)

***References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

***Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header